

Attorney Docket # 5367-47RCE

Patent

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of

Stefan BADER et al.

Serial No.: 10/696,882

Filed: October 30, 2003

For: Method for Depositing a Material on a
Substrate Wafer

Examiner: RAO, G. Nagesh
Group Art: 1722

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December 26, 2006
(Date of Deposit)

Thomas Langer

Name of applicant, assignee or Registered Representative

Thomas Langer
Signature

December 26, 2006
Date of Signature

PETITION FOR EXTENSION OF TIME UNDER 37 C.F. R. § 1.136(a)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

- ☒ This is the first request for an extension of time relative to the outstanding paper. Please grant a two-month extension of time. Payment for the extension fee of \$450.00 is enclosed. With this extension, the deadline for filing the required paper will be extended to December 24, 2006.
- ☐ This is not the first request for an extension of time relative to the outstanding paper. The period for response has already been extended by -month(s) by petition dated . Please extend the time for response by an additional -month(s). With this extension, the deadline for filing the required paper will be . A check for the additional extension fee of \$ is enclosed.
- ☒ Please charge any additional fees, or credit any overpayment, to Deposit Account No. 03-2412. A duplicate copy of this sheet is enclosed.

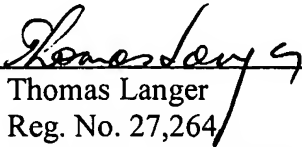
01/03/2007 CCHAU1 00000063 10696882

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- ☐ Small entity status has already been established or is being established by a paper filed herewith.

Respectfully submitted,
COHEN PONTANI LIEBERMAN & PAVANE LLP

By 
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Dated: December 26, 2006